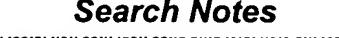


Search Notes 	Application/Control No. 10/706,916	Applicant(s)/Patent under Reexamination CHEN, MEI HUI
Examiner Jeff H. Aftergut	Art Unit 1733	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner